



ELECTRONIC COPY

LG653442506
Report verification at igi.org



September 23, 2024

IGI Report Number **LG653442506**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **6.34 - 6.38 X 3.95 MM**

GRADING RESULTS

Carat Weight **1.00 CARAT**

Color Grade **D**

Clarity Grade **VVS 2**

Cut Grade **EXCELLENT**

September 23, 2024
IGI Report Number **LG653442506**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **ROUND BRILLIANT**
Measurements **6.34 - 6.38 X 3.95 MM**

GRADING RESULTS

Carat Weight **1.00 CARAT**

Color Grade **D**

Clarity Grade **VVS 2**

Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

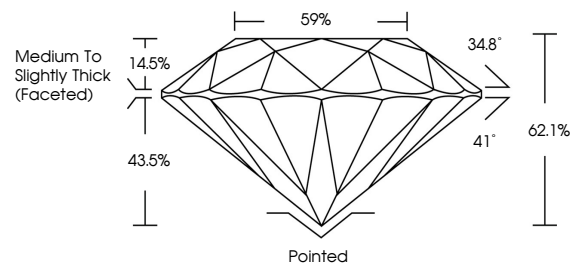
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG653442506**

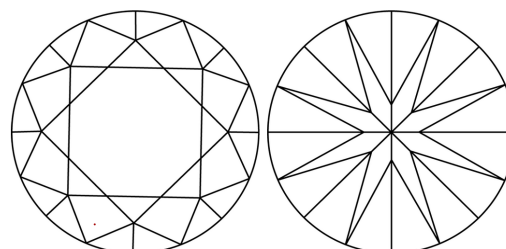
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

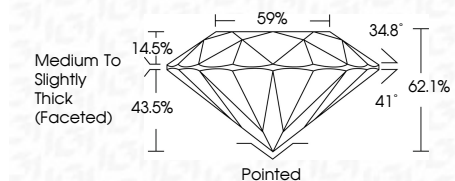
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG653442506**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI



September 23, 2024	1.00 CARAT	D	VVS 2	EXCELLENT	62.1%	59%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG653442506
IGI Report No LG653442506	Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Grade	Culet	Polish	Symmetry	Fluorescence	Inscription(s)
ROUND BRILLIANT	6.34 - 6.38 X 3.95 MM	D	VVS 2	EXCELLENT	62.1%	59%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG653442506

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa